

Docket No.: 55071-267

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Stephen Duan-Fu HSU, et al. : Confirmation Number: 9799

Serial No.: 10/626,858 : Group Art Unit:

Filed: July 25, 2003 : Examiner:

For: ORIENTATION DEPENDENT SHIELDING FOR USE WITH DIPOLE

ILLUMINATION TECHNIQUES

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the

10/626,858

foreign search report or office action, together with an English language version thereof, is

attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

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Respectfully submitted,

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Date: May 11, 2004

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		(PT	O-1449)		FILING DATE July 25, 2003						
				U.S. PATE	NT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	1	Document Number per-Kind Code2 (1 known)	Publication Date MM-DD-YYYY		Name of Patentee or Applicant of Cited Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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				<u> </u>	or, Title, Date, Pertinent Pages						
EXAMINER'S INITIALS											
		HSU, Stephen D., et al. "65 nm Full-chip Implementation Using Double Dipole Lithography." Optical Microlithography XVI, Santa Clara, California, USA, February 2003, Proceedings of the SPIE- The International Society for Optical Engineering, pp. 215-231, XP 009024366, ISSN: 0277-786X									
		HSU, Stephen D., et al. "Dipole Decomposition Mask-design for full Chip Implementation at the 100nm Technology Node and Beyond." Proceedings of the SPIE, US, Volume 4691, pp. 476-490, XP 002261072, ISSN: 0277-786X									
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LIM, Chang-Moon., et al. "Intra-field CD Variation by Stray Light from Neighboring Field." Optical Microlithography XV, Santa Clara, California, USA, March 2002, Proceedings of the SPIE- The International Society for Optical Engineering, 2002, pp.1412-1420, XP 002268484, ISSN: 0277-786X											
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EXAMINER					DATE CONSIDERED						

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.